Docket No.: 2019-0215P

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Chih-Kun CHEN et al.

Application No.: 10/655,224

Filed: September 5, 2003

For: WAFER CLEANING APPARATUS WITH

MULTIPLE WASH-HEADS

Confirmation No.: 6986

Art Unit: 1746

Examiner: Sarah E. HUSBAND

## **AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **INTRODUCTORY COMMENTS**

In response to the Office Action dated October 10, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 10 of this paper.